

Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

JUN 30 2005

Docket Number (Optional)

MEG-02-015

Application Number

10/685,872

Applicant

M.S. Lin

Filing Date

10/15/03

Group A1 Unit

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
W	6187680	2/13/01	Castrini et al.	438	688	10/7/98
	6232147	5/15/01	Matsuki et al.	438	108	8/2/99
	6229221	5/8/01	Kloen et al.	257	784	12/6/99
	6472745	10/29/02	Iizuka	257	723	1/14/00
W	6200888	3/13/01	Ito et al.	438	597	5/4/00

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Portion of Pages, Etc.)

W	U.S. Patent App. Pub. U.S. 2002/0158334 A1 to Vu et al., Pub. Date 10/31/02, Filed 4/30/01, U.S. Cl. 257/723.

EXAMINER

H. P. R. R. R.

DATE CONSIDERED

1/14/06

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>28</i>	6495442	12/17/02	Lin et al.	438	618	10/18/00
	6383916	5/7/02	Lin	438	637	2/17/99
	6303423	10/14/01	Lin	438	238	11/27/00
	6649509	11/18/03	Lin et al.	438	618	10/24/01
	5659201	8/19/97	Wollesen	257	758	6/5/95
<i>28</i>	6187680	2/13/01	Costrini et al.	438	688	10/7/98

FOREIGN PATENT DOCUMENTS

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						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>28</i>	-	U.S. Patent App. Pub. US 2003/0222295 A1 to Lin, Pub. Date 12/4/03, Filed 5/27/03, US Cl. 257/300.
<i>28</i>	-	U.S. Patent App. Pub. US 2002/0158334 A1 to Vu et al., Pub. Date 10/31/02, Filed 04/30/01, US Cl. 257/723.

EXAMINER

M. Picardat

DATE CONSIDERED

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